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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/812,087	03/30/2004	Akitaka Makino	648.43120CX1	3009	
20457 75	20457 7590 03/30/2005			EXAMINER	
ANTONELLI, TERRY, STOUT & KRAUS, LLP 1300 NORTH SEVENTEENTH STREET			MOORE, KARLA A		
SUITE 1800			ART UNIT	PAPER NUMBER	
ARLINGTON,	VA 22209-3873		1763		

DATE MAILED: 03/30/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

	W)		(
	Application No.	Applicant(s)	
	10/812,087	MAKINO ET AL.	
Office Action Summary	Examiner	Art Unit	
	Karla Moore	1763	•
The MAILING DATE of this communication Period for Reply	appears on the cover she	et with the correspondence a	ddress
A SHORTENED STATUTORY PERIOD FOR RE THE MAILING DATE OF THIS COMMUNICATIO - Extensions of time may be available under the provisions of 37 CFI after SIX (6) MONTHS from the mailing date of this communication - If the period for reply specified above is less than thirty (30) days, a - If NO period for reply is specified above, the maximum statutory pe - Failure to reply within the set or extended period for reply will, by st Any reply received by the Office later than three months after the m earned patent term adjustment. See 37 CFR 1.704(b).	DN. R 1.136(a). In no event, however, m . I reply within the statutory minimum riod will apply and will expire SIX (6) atute, cause the application to become	ay a reply be timely filed of thirty (30) days will be considered time MONTHS from the mailing date of this one and ABANDONED (35 U.S.C. § 133).	ely. communication.
Status			
1)⊠ Responsive to communication(s) filed on 3	0 March 2004		
<u> </u>	This action is non-final.		
3) Since this application is in condition for allo		matters, prosecution as to th	e merits is
closed in accordance with the practice und		·	
Disposition of Claims			·
4)⊠ Claim(s) <u>4-6</u> is/are pending in the application	· on		
4a) Of the above claim(s) is/are with			
5) Claim(s) is/are allowed.			
6)⊠ Claim(s) <u>4-6</u> is/are rejected.	•		
7) Claim(s) is/are objected to.			
8) Claim(s) are subject to restriction ar	d/or election requirement		
Application Papers			
9) The specification is objected to by the Exam	niner.		
10)⊠ The drawing(s) filed on 30 March 2004 is/ar		objected to by the Examine	r.
Applicant may not request that any objection to	the drawing(s) be held in ab	eyance. See 37 CFR 1.85(a).	
Replacement drawing sheet(s) including the co			
11)☐ The oath or declaration is objected to by the	Examiner. Note the attached	ched Office Action or form P	TO-152.
Priority under 35 U.S.C. § 119			
12) Acknowledgment is made of a claim for fore a) All b) Some * c) None of:	eign priority under 35 U.S.	C. § 119(a)-(d) or (f).	
 Certified copies of the priority docum 	ents have been received.		
2. Certified copies of the priority docum		· · · · · · · · · · · · · · · · · · ·	
3. Copies of the certified copies of the p		een received in this National	l Stage
application from the International But	• • • • • • • • • • • • • • • • • • • •		
* See the attached detailed Office action for a	iist of the certified copies	not received.	
Attachment/s)			
Attachment(s) Notice of References Cited (PTO-892)	4) ☐ Inton	ew Summary (PTO-413)	
2) 🔲 Notice of Draftsperson's Patent Drawing Review (PTO-948)	Paper	No(s)/Mail Date	
 Information Disclosure Statement(s) (PTO-1449 or PTO/SB Paper No(s)/Mail Date <u>0304</u>. 		e of Informal Patent Application (PT	O-152)
5. Patent and Trademark Office	e Action Summary		A-ii D-4 cos-
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Application/Control Number: 10/812,087 Page 2

Art Unit: 1763

DETAILED ACTION

Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 2. Claims 4 and 6 are rejected under 35 U.S.C. 102(b) as being anticipated by U.S. Patent No. 5,884,009 to Okase.
- 3. Okase discloses a vacuum processing apparatus in Figure 1, comprising a vacuum processing chamber (column 6, rows 37 and 38) having a processing table (24) for supporting an object (W) to be processed and carrying out processing using a gas (using process gas supply unit, 5), the vacuum processing chamber having an axisymmetric structure (see overhead view of Figure 6), wherein the vacuum processing chamber has a double wall structure (inner and outer cylindrical vessels, 1 and 2) and comprises a gate valve (13; column 8, rows 38-40) for sealing an opening through which the object enters the processing chamber.
- 4. Okase further discloses a vacuum processing apparatus in Figure 1, comprising a vacuum processing chamber (column 6, rows 37 and 38) having a processing table (24) for supporting an object (W) to be processed and carrying out processing using a gas (using process gas supply unit, 5), the vacuum processing chamber having an axisymmetric structure (see overhead view of Figure 6) with respect to the object to be processed, wherein the vacuum processing chamber has a double wall structure (inner and outer cylindrical vessels, 1 and 2) and comprises a gate valve (13; column 8, rows 38-40) for sealing an opening formed to the chamber wall through which the object enters the processing chamber; and an inner vacuum processing chamber has a wall divided into two portions, and upper portion (above opening 41) and a lower portion (below opening 41), with the processing table interposed between the two portions.

Application/Control Number: 10/812,087 Page 3

Art Unit: 1763

5. Claim 5 is rejected under 35 U.S.C. 102(b) as being anticipated by U.S. Patent No. 6,192,827 to Welch et al.

Welch et al. disclose a vacuum processing apparatus in Figures 1-2 and 5 comprising a vacuum processing chamber (abstract) having a processing table (Figure 5, 220; column 6, rows 59-62) for supporting an object/substrate to be processed and carrying out processing using a gas (column 1, rows 27-28), the vacuum processing chamber having an axisymmetric structure (see overhead view of Figure 1) with respect to the object to be processed, wherein the vacuum processing chamber has a double wall structure (chamber body, 24 and liner 50) and comprises a gate valve (60) for sealing an opening formed to the chamber wall through which the object enters the processing chamber; and the shape of the gate valve for sealing the opening formed to the inner vacuum processing chamber is determined so that it does not interfere with the axisymmetric structure of the vacuum processing chamber (see Figures 2, 3B and 5; column 2, rows 11-20 and column 4, rows 32-35).

Conclusion

7. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

USP 5,592,581 discloses a processing apparatus with a double-walled structure.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Karla Moore whose telephone number is 571.272.1440. The examiner can normally be reached on Monday-Friday, 8:30am-5:30pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Parviz Hassanzadeh can be reached on 571.272.1435. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Application/Control Number: 10/812,087

Art Unit: 1763

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC)

Page 4

Karla Moore Patent Examiner Art Unit 1763 28 March 2005

at 866-217-9197 (toll-free).